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Attorney Docket: 071469-0309182  
Client Reference: PC6042A2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 8235

PANDA SIDDHARTHA , ET AL.

Application No : 10/821,201

Group Art Unit: 1763

Filed: April 9, 2004

Examiner: George A. GOUDREAU

Title: METHOD AND SYSTEM FOR DEEP TRENCH SILICON ETCH

AMENDMENT AFTER-FINAL

Mail Stop AF  
Commissioner for Patents  
P O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 18, 2006, please amend the above-identified application as follows and consider the following remarks: